Application Number:	10659213					
Filing Date:	10-Sep-2003					
Title of Invention:	Substrate processing apparatus					
First Named Inventor/Applicant Name:	Katsuhiko Miya					
Filer:	Max Moskowitz/Cheryl Godfrey					
Attorney Docket Number:	P/1250-261					
Filed as Large Entity	•			• _ <		
Utility Filing Fees		_ ~ ~ ,			162	
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:	1		ll.	1		
Pages:						
Claims:						
Miscellaneous-Filing:						
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
Extension-of-Time:						

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)				
Miscellaneous:								
Request for continued examination	1801	1	790	790				
	Tota	910						